Jochen Stahn

Laboratorium für Neutronenstreuung ETH Zürich & Paul Scherrer Institut

A neutron polariser based on magnetically remanent Fe/Si supermirrors

ILL, Grenoble

18.01.2006

neutron optics group PSI: Jochen Stahn Murat Ay Christian Schanzer Jay Padiyath Michael Horisberger

cooperation partners: NMI3–JRA3–NO HMI, TUM, etc.

funding:NMI3HII3-CT-2003-505925MaNEPproject 6, MesotSNF200021-101567

introduction multilayer, supermirror

reflectometers at SINQ Amor, Morpheus, Narziss

topics of the neutron optics group at PSI supermirrors, interfaces focusing devices, polariser

magnetically remanent neutron polarisers principle production applications



multilayer:

causes 'Bragg peaks'



multilayer: causes 'Bragg peaks'
stack of multilayers: overlapping 'Bragg peaks'



multilayer:causes 'Bragg peaks'stack of multilayers:overlapping 'Bragg peaks'supermirror:'multilayer' with layer-thickness gradient



instruments

SINQ: continuous flux spallation source

 \Rightarrow combination of the disadvantages of reactor- and spallation sources!

flux: $10^{14} \text{ n/cm}^2\text{s}$ cold source: liquid deuterium



7

instruments Amor



TOF reflectometer, user instrument

$$- \ 0 \ \text{\AA}^{-1} < q_z < 0.4 \ ext{\AA}^{-1}$$
, $\Delta q_z/q_z > 0.5 \ \%$

- single counter and area detector
- polarisation option(with analysis)



instruments Morpheus

test diffractometer and reflectometer

for in-house research and sample alignments

- angle-dispersive
- -2Å $<\lambda<$ 7Å,
- single counter and area detector
- all SINQ sample environment ($H < 1 \,\mathrm{T}$)
- 4-circle set-up
- polarisation option

(with analysis)









instruments Narziss

cooperation with SwissNeutronics

new reflectometer, dedicated to neutron optics research, only.

 $-\lambda = 5 \text{ Å}$

- polarisation option, with analysis
- sample magnet $-1000\,\mathrm{Oe} < H < 1000\,\mathrm{Oe}$ $600 \times 150 \times 50\,\mathrm{mm^3}$











topics of the neutron optics group

- high-*m*-sm &
 band-pass filters
- interface design
- *fundamental* monochromators
- focusing devices
- remanent polarisers

topics high-*m*-**sm** / **band pass filter**

ideas:

- prevent interdiffusiom by introducing a blocking layer
- flaten the accumulated roughness by substituting some layers by a smoothening material as e.g. Cr

works good for not too many layers! fails for m > 2.5.



topics interface design

non-sharp but laterally homogeneous interfaces

- annealing: interdiffusion

limited by diffusion length, melting

and grain-formation/growth \Rightarrow roughness

- artificial intermixing:

intermediate films between the layers



topics fundamental monochromator

extreme limit: sinusoidal profile

 \Rightarrow only fundamental Bragg peak, no higher harmonics



applications:

- monochromator
- wavelength filter(*e.g.* for Narziss)





topics focusing devices

bi-elliptic neutron guide

built by SwissNeutronics





Distance from beam axis x [mm]

1:10 model of a neutron guide. ideally only 2 reflections from source to image openings: $4 \times 8 \text{ mm}^2$, length: 2 m



topics remanent polarisers

. . . fills rest of the presentation!

remanent polariser application principle



remanent polariser material

ferromagnetic material: Fe

- might show easy axis of magnetisation
- almost matches Si for |angle
- low absorption (required for transmission, less radiation damage)

spacer material: Si

- low potential
- matches the substrate (for transmission)
- low absorption
- can be influenced (potential and stress) by reactive sputtering

but

- rather low contrast for |+
 angle
 - \Rightarrow larger number of layers reqired
- total reflection for low q

remanent polariser ideal ml



remanent polariser real ml: Fe/Si:N:O



remanent polariser magnetic properties

anisotropic in-plane stress causes anisotropic magnetic properties (magnetostriction)

reason: shape of sputter target and aperture (ca. $100 \times 400 \text{ mm}^2$) \Rightarrow spread of angle of incidence of sputtered atoms is anisotropic \Rightarrow growth and thus strain formation is effected \Rightarrow easy axis of magnetisation requires strained filmes!



remanent polariser

production

all our multilayers are produced by magnetron sputtering:

parameters:

- power
- velocity
- Ar gas pressure
- reactive gases (O_2, N_2)
- apertures

properties of the films:

- contrast (matching)
- stress minimisation (stable films)
- anisotropic stress (to get an easy axis of magnetisation)
- interface quality (roughness, interdiffusion)



remanent polariser sputter plant

sputter-plant: Leybold Z600

- cleaning of the substrates
 by glow discharge
- 3 cathods
- 1+3 gas inlets per cathod





aperture used to increase the anisotropy and thus the remanence

consequences:

- unstable discharge
- lower deposition rate
- no influence on the magnetic properties

remanent polariser performance



remanent polariser performance



remanent polariser H_c vs. layer thickness

saturation in $H = -700 \,\mathrm{Oe}$

transmission measured in guide fields

$$H_{\rm g} = +5\ldots + 45 \,{
m Oe}$$





remanent polariser off-specular scattering

polarised beam, no spin analysis Fe/Si:N:O sm, m = 2.4

assymetric off-specular signal

 \Rightarrow weak spin-flip scattering



remanent polariser applications: analyser

at Morpheus, Narziss (SINQ)

coating Fe / Si:N:O m = 3, 599 layers substrate Si-wafer, 0.6 mm mirror size $200 \times 60 \text{ mm}^2$ magnet size $200 \times 100 \times 100 \text{ mm}^3$ By 200 Op

$$B_{\rm M}$$
 200 Oe
 $B_{\rm g}$ 20 Oe
 $P_{\rm T, \uparrow\uparrow}$ > 97 %
 $P_{\rm T, \uparrow\downarrow}$ > 95 %



remanent polariserapplications: switchable polariserat Amor (SINQ)

- FeCoV/TiN on glas
- operated in reflection mode
- saturation fields: $\pm 400 \, \text{Oe}$
- guide field: +20 Oe







remanent polariser at SANS I (SINQ)



applications: white beam polariser

coating

conclusion:

we produced supermirrors with Fe and Si:N:O which

- polarise neutrons (P > 95% to P = 99%)

- can be operated in transmission and reflection mode
- show a magnetic remanence
- thus need guide fields of 20 Oe, only
- can be operated antiparallel to the guide field

the reactive gases N₂ and O₂ in Si are needed to

- match the potentials for |angle
- tailor strain in Fe layers (anisotropic stress), but
- keep the overall stress small

limitations:

- stress limits the number of layers $\Rightarrow m < 3$
- FeSi layer causes 2nd Bragg peak $\Rightarrow |-\rangle$ contamination in reflection mode

